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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

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TECHNOLOGY CENTER 280C

In re Application of:

Farnworth et al.

Serial No.: 09/589,841

Filed: June 8, 2000

For: STEREOLITHOGRAPHIC
METHODS FOR FORMING A
PROTECTIVE LAYER ON A
SEMICONDUCTOR DEVICE
SUBSTRATE AND SUBSTRATES
INCLUDING PROTECTIVE
LAYERS SO FORMED

Examiner: G. Lee

Group Art Unit: 2825

Attorney Docket No.: 3923US (99-0033)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail (under 37 C.F.R. § 1.8(a)) on the date of deposit shown below with sufficient postage and in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

August 22, 2002
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Deidra Pfeil

Typed/printed name of person whose signature is contained above

AMENDMENT

Box NON FEE-AMENDMENT
Commissioner for Patents
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed May 22, 2002, the three-month shortened statutory period for response to which expires on August 22, 2002.